

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Kaoru YAMADA et al. : **Mail Stop: PCT**
Serial No. NEW : Attorney Docket No. 2006-0044A
Filed January 18, 2006 :

SUBSTRATE PROCESSING APPARATUS, THE COMMISSIONER IS AUTHORIZED
SUBSTRATE PROCESSING METHOD, AND TO CHARGE ANY DEFICIENCY IN THE
SUBSTRATE HOLDING APPARATUS FEES FOR THIS PAPER TO DEPOSIT
[Corresponding to PCT/JP2004/011101 ACCOUNT NO. 23-0975
Filed July 28, 2004

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced U.S. patent application please amend the application as follows: